

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/780,713	PARK, JAE-YEONG
	Examiner	Art Unit
	Scott R. Wilson	2826

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
257	125 414-416	2/11/05	SM
438	48,49 50	/	/
333	188,195 133		
310	312,364	▼	▼